INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 9, 2025

IGI Report Number	LG589323152
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	9.73 X 6.91 X 5.14 MM

GRADING RESULTS

Carat Weight	2.97 CARATS
Color Grade	E
Clarity Grade	VS 1

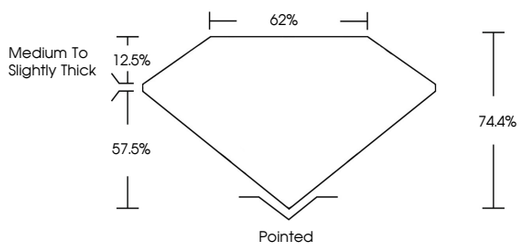
ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG589323152

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG589323152
Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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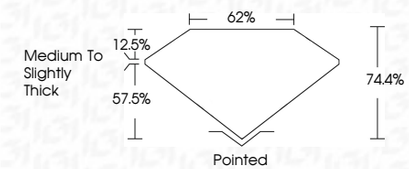

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CUT CORNERED RECT. MODIFIED BRILLIANT
9.73 X 6.91 X 5.14 MM

Carat Weight	2.97 CARATS
Color Grade	E
Clarity Grade	VS 1
Depth	74.4%
Table	62%
Girdle	Medium To Slightly Thick
Culet	Pointed
Polish	VERY GOOD
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG589323152

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